S/N 09/945,535

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kie Y. Ahn et al. Examiner: Colleen E. Rodgers

 Serial No.:
 09/945,535
 Group Art Unit: 2813

 Filed:
 August 30, 2001
 Docket: 1303.026US1

Title: HIGHLY RELIABLE AMORPHOUS HIGH-K GATE OXIDE ZRO2

COMMUNICATION CONCERNING RELATED APPLICATIONS

MS AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Applicants would like to bring to the Examiner's attention the following related applications in the above-identified patent application:

Serial/Patent No. Filing Date/Issue Date Attorney Docket Title

11/737,460 April 19, 2007 1303.135US2 ALD OF AMORPHOUS LANTHANIDE DOPED TIOX FILMS

11/735,247 April 13, 2007 1303.127US2 HAFNIUM TANTALUM OXIDE DIFLECTRICS

Continuations and divisionals may be later filed on the cases listed above, or cited to the Examiner in any previous Communication Concerning Related Applications. Applicants request that the Examiner review all continuations and divisionals of the above-listed or previously-cited patent applications before allowing the claims of the present patent application.

Respectfully submitted.

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